INTERNATIONAL SEARCH REPORT

International application No. PCT/AU2004/001118

A.	CLASSIFICATION OF SUBJECT MATTE	R							
Int. Cl. 7:	B82B 3/00, H01L 23/544								
According to	International Patent Classification (IPC) or to	both r	national classification and IPC						
B.	FIELDS SEARCHED								
Minimum docu	mentation searched (classification system follower	d by cla	ssification symbols)						
Documentation	searched other than minimum documentation to t	the exter	nt that such documents are included in the fields search	ned					
DWPI and k			lata base and, where practicable, search terms used) rence; silicon, substrate; SEM, microscope,	STM; image,					
C.	DOCUMENTS CONSIDERED TO BE RELEVA	ANT							
Category*	Citation of document, with indication, whe	ropriate, of the relevant passages	Relevant to claim No.						
A	WO 2003/019635 A1 (UNISEARCH I See entire document	LIMIT	ED) 6 March 2003						
A	WO 2002/019036 A1 (UNISEARCH LIMITED) 7 March 2002 See entire document								
A	Patent Abstracts of Japan JP 2000-150 See abstract)358 A	(HITACHI LTD) 30 May 2000						
	·			-					
X	Further documents are listed in the contir	nuation	n of Box C X See patent family ann	ex					
"A" docum	nsidered to be of particular relevance	C:	ter document published after the international filing date or ponflict with the application but cited to understand the principal the invention ocument of particular relevance; the claimed invention cannot be compared to the claimed to t	ple or theory					
	tional filing date	O	r cannot be considered to involve an inventive step when the lone						
or whi	ent which may throw doubts on priority claim(s) the is cited to establish the publication date of the citation or other special reason (as specified)	ir	ocument of particular relevance; the claimed invention cannon the new an inventive step when the document is combined with such documents, such combination being obvious to a person	h one or more other					
"O" docum	ent referring to an oral disclosure, use, exhibition		ocument member of the same patent family						
	ent published prior to the international filing date er than the priority date claimed								
Date of the ac	etual completion of the international search		Date of mailing of the international search report						
	illing address of the ISA/AU		Authorized officer						
AUSTRALIA	N PATENT OFFICE	•							
E-mail addres	, WODEN ACT 2606, AUSTRALIA ss: pct@ipaustralia.gov.au		RAJEEV DESHMUKH						
Facsimile No.	. (02) 6285 3929		Telephone No: (02) 6283 2145						

INTERNATIONAL SEARCH REPORT

International application No.

PCT/AU2004/001118

Category*	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to
	**************************************	claim No.
. , A	SCHENKEL, T et al., Single Ion Implantation for Solid State Quantum Computer Development [online], Proceedings of the 46 th International Conference on Electron, Ion and Photon Beam Technology and Nanofabrication, Anaheim, May 2002, J. Vac. Sci. Technol. B, in press [retrieved on 2004-10-08]. Retrieved from the Internet: <url: ebit.lbl.gov="" http:="" jovsatb-2002-schenkel.pdf="" publications=""></url:>	
A, P	WO 2003/081687 A2 (INTERNATIONAL BUSINESS MACHINES CORPORATION) 2 October 2003 See entire document	
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INTERNATIONAL SEARCH REPORT

Information on patent family members

International application No.

PCT/AU2004/001118

This Annex lists the known "A" publication level patent family members relating to the patent documents cited in the above-mentioned international search report. The Australian Patent Office is in no way liable for these particulars which are merely given for the purpose of information.

Patent Document Cited in Search Report					•		
wo	03019635						
wo	0219036	AU	81594/01	EP	1328847	US	2004029050
JР	2000150358						
wo	03081687	US	2003178617				

Due to data integration issues this family listing may not include 10 digit Australian applications filed since May 2001.

END OF ANNEX